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First Named Inventor	Kyle K. Kirby	<b>INFORMATION DISCLOSURE STATEMENT FORM PTO-1449</b>
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Examiner Name	<del>Unknown</del> SMOOT	
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	Country	No.			

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S.W.S.	B. King, M. Renn and M Essien, M <sup>3</sup> D Technology, Maskless Mesoscale™ Materials Deposition, "M <sup>3</sup> D Technology deposits electronic materials onto low-temperature, non-planar substrates without masks or resists," Optomec, Inc.
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Examiner Signature	<i>Stephen W. Smoot</i>	Date Considered	July 22, 2004
<small>*Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>			